

Attorney Docket: 040021-0306769 Client Reference: OPP 031059 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In PATENT APPLICATION of: CHOI

Confirmation Number: 3859

RATTA Application No.: 10/735,912

Group Art Unit: 1763

Filed: December 16, 2003

Examiner: Jeffrie Lund

Title: CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the one-month Office Action dated December 5, 2005, Applicant elects Group I, encompassing claims 1-8, drawn to a CVD apparatus, for examination in this application without traverse.

Applicant maintains the right to file a divisional application for non-elected claims in Group II at a later time and respectfully requests an early and favorable examination on the merits of the elected claims.

Respectfully submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP

JEFFREY D. KARCESKI

Reg. No. 35914

Tel. No. 703 770.7510 Customer No. 00909

Date: January 4, 2006 P.O. Box 10500 McLean, VA 22102 (703) 770-7900